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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of: )  
TZENG ) Examiner:  
Serial No.: 09/501,114 ) Art Unit:  
Filed: February 10, 2000 )  
For: **METHOD OF PLASMA ENHANCED** )  
**CHEMICAL VAPOR DEPOSITION** )  
**OF DIAMOND** )

**INFORMATION DISCLOSURE STATEMENT**  
**PURSUANT TO 37 C.F.R. § 1.97 ET SEQ.**

Assistant Commissioner of Patents  
Washington, D.C. 20231

Sir:

Listed on the accompanying form PTO-1449 are a number of documents that may be considered material to the examination of this application. A copy of each of these documents is provided herewith.

Applicant reserves the right to establish the patentability of the claimed invention over any of the listed documents should they be applied as references, and/or to prove that some of these documents may not be prior art, and/or to prove that some of these documents may not be enabling for the teachings they purport to offer.

This statement further should not be construed as a representation that an exhaustive search has been made, or that there does not exist information more material to the examination of the present application. The Examiner is specifically requested not to rely solely on the materials

submitted herewith. The Examiner further is requested to conduct an independent and thorough review of the documents, and to form independent opinions as to their significance.

It is respectfully requested that the Examiner initial and return a copy of enclosed PTO-1449, and to similarly indicate in the Official File Wrapper for this patent application that the documents have been considered.

Respectfully submitted,

  
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Docket No.: A029 1080

CERTIFICATE OF MAILING

I hereby certify that this document is being deposited as first class U.S. Mail, in an enveloped addressed to: Assistant, Commissioner for Patents, Box IDS, Washington, D.C. 20231 on

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